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BY APPLICANTS

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Applicant

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U.S. PATENTS/APPLICATIONS

Examiner's Initial	Document Number	Date	Name	Class/Sub-class
18P	US 2002/0030246 A1	03/14/2002	Eisenbeiser et al.	257/629

FOREIGN PATENT DOCUMENTS

Examiner's Initial	Document Number	Date	Country/Name	Translation? yes/no
	NONE			

OTHER DOCUMENTS

not complied with WPI 3P 609
1. ~~ULLRICH et al., Preparation of Thin Film GaAs on Glass by Pulsed-Laser Deposition,~~
~~Proceedings of SPIE, Vol. 4977 (2003).~~

Examiner	/Thanhha Pham/	Date Considered	04/05/2007
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